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03500.017666.

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: Jeffery T. Barton
TAKAHARU KONDO, et al.	)	
	:	Group Art Unit: 1753
Application No.: 10/693,914	)	
	:	
Filed: October 28, 2003	)	
	:	
For: ZINC OXIDE FILM,	)	
PHOTOVOLTAIC DEVICE	:	
MAKING USE OF THE SAME,	)	
AND ZINC OXIDE FILM	:	
FORMATION PROCESS	)	January 18, 2006

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449.

The listed documents were cited in an Office Action issued in a counterpart Chinese patent application. A copy of the Chinese Office Action, which is dated December 12, 2005, together with an English-language translation of the Office Action, is enclosed. JP 2002-167695 cited in the Search Report was previously cited in the March 29, 2004 Information Disclosure Statement.

This Information Disclosure Statement is being filed before the issuance of a first Office Action on the merits. Therefore, no fee under 37 C.F.R. § 1.97(c)(2) is believed due. Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should any fee be due for filing this paper.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Costa Mesa, California office at (714) 540-8700. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,



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